

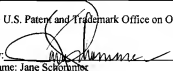
S/N 10/565716

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	MURAKAMI, ET AL.	Examiner:	HA, NGUYEN T
Serial No.:	10/565716	Group Art Unit:	2831
Filed:	January 25, 2006	Docket No.:	20162.0012USWO
Title:	METHOD FOR FORMING OXIDE FILM ON METAL SURFACE USING IONIC LIQUID, ELECTROLYTIC CAPACITOR AND ELECTROLYTE THEREOF		

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/NH/

<p><b>CERTIFICATE OF TRANSMISSION</b> I hereby certify that this paper is being transmitted by EFS Web to the U.S. Patent and Trademark Office on October 8, 2010.</p> <p>By:  Name: Jane Schormiller</p>
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**AMENDMENT AFTER FINAL**

Mail Stop: AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Commissioner:

In response to the Office Action mailed July 8, 2010, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.